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12/18/01

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10022316	12/18/2001	438		2814	LOUIE, W

**APPLICANTS: Tischler Michael; *WSL*

**CONTINUING DATA VERIFIED: *WSL*

** FOREIGN APPLICATIONS VERIFIED: *WSL*

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☒ no
35 USC 119 conditions met ☐ yes ☒ no

Verified and Acknowledged Examiners's initials *WSL*

ATTORNEY DOCKET NO

ATMI-477

TITLE : Wafer carrier for semiconductor process tool

U S DEPT OF COMM /PAT & TM-PTO-435L(Rev 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G
Assistant Examiner			
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg. Print Fig.
		Primary Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
		Applicati n Examiner	
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